



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(211.001-D2-US)

In re Application of: **FAZAN ET AL.**

) Group Art Unit:

Serial No: **10/724,377**

) Examiner:

Filing Date: **NOVEMBER 28, 2003**

)

Title: **SEMICONDUCTOR DEVICE**

)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence
is being deposited with the United States
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22313-1450 on July 29, 2004
Date

Michiko Siter
(person signing this certificate)

Michiko Siter
Signature

THIRD PRELIMINARY AMENDMENT

Dear Sir:

Prior to the examination of the above-referenced application, kindly amend the application as follows: